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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaharu KAWAKUBO et al.

Group Art Unit: 4175

Application No.: 10/581,060

Examiner: C. RIDDLE

Filed: May 30, 2006

Docket No.: 127873

For: EXPOSURE METHOD AND DEVICE MANUFACTURING METHOD, EXPOSURE APPARATUS, AND PROGRAM

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the December 8, 2008 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**